



Docket No. YOR920030175US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

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Applicant(s): Allen et al.
Case: YOR920030175US1
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10 Group: 2811
Examiner: Cuong Q. Nguyen

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: *Susan Fortune* Date: November 1, 2005

Title: Techniques for Patterning Features in Semiconductor Devices

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RESPONSE AFTER FINAL REJECTION

20 Mail Stop AF
Commissioner for Patents
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25 Sir:

In response to the outstanding final Office Action dated July 1, 2005, Applicants submit the following remarks.